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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takao ABE et al.

Group Art Unit: 1765

Application No.: 09/743,982

Examiner: M.A. Anderson

Filed: January 18, 2001

Docket No.: 108360

For: SILICON SINGLE CRYSTAL AND WAFER DOPED WITH GALLIUM AND
METHOD FOR PRODUCING THEM

REQUEST FOR TERMINATION OF SUSPENSION OF ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In conjunction with entry of the accompanying Supplemental Preliminary
Amendment, Applicants respectfully request termination of the suspension of action under 37
C.F.R. §1.103(c), and prompt and favorable action on the merits of this application.

Respectfully submitted,


William P. Berridge
Registration No. 30,024


Julie M. Seaman
Registration No. 51,156

WPB:JMS/jam

Date: July 22, 2003

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